

OFFICIAL**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. 09/677,478
Filing Date **RECEIVED** October 2, 2000
Inventor **CENTRAL FAX-CENTER** Guy T. Blalock
Assignee **DEC 18 2003** Micron Technology, Inc.
Group Art Unit 1765
Examiner Lan Vinh
Attorney's Docket No. MI22-1544
Title: Plasma Etching Methods

RESPONSE TO SEPTEMBER 18, 2003 OFFICE ACTION

To: Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: D. Brent Kenady
Tel. 509-624-4276; Fax 509-838-3424
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Responsive to the Office Action dated September 18, 2003, Applicant
amends and remarks as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.